# CENTRAL PAY CENTER

## JAN 3 1 2006

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Jack O. Chu, et al.

**Examiner:** 

Johannes P. MONDT

Serial No:

10/775,514

**Art Unit:** 

3663

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For: EPITAXIAL AND POLYCRYSTALLINE

GROWTH OF  $Si_{1-x-y}$   $Ge_xC_y$  AND  $Si_{1-y}C_y$ 

ALLOY LAYERS ON SI BY UHV-CVD

Confirmation Number: 1038

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

### RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

In response to the December 21, 2005 Advisory Action, in which the Examiner refused to enter the proposed claim amendments in Applicant's December 9, 2005 Response to Final Office Action, Applicants hereby expressly withdraw the previously proposed claim amendments and submit the following amendments and remarks for entry of record instead in the above-identified patent application.

#### **CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that this document is being filed in the United States Patent and Trademark Office on the date shown below via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 at United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

Land Committee Committee

Dated: January 31, 2006

Leslie S. Szivos, Ph.D.